

Electronic Patent Application Fee Transmittal

Application Number:	10581522			
Filing Date:	13-Feb-2007			
Title of Invention:	Plasma Processing Apparatus and Multi-Chamber System			
First Named Inventor/Applicant Name:	Toshiaki Fujisato			
Filer:	Marvin Jay Spivak/Jeanette Herbert			
Attorney Docket Number:	292147US26PCT			
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U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
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Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	130	130

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				130